

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTORNEY'S DKT NO. 000348-280	APPLICATION NO. Not Assigned
	APPLICANT Bernard DREVILLON et al	
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U.S. PATENT DOCUMENTS				
Examiner Initials	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication (MM-DD-YYYY)
	Number	Kind Code (if known)		

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Foreign Patent Document		Country	Date of Publication (MM-DD-YYYY)	Translation	
	Number	Kind Code (if known)			Yes	no

NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
CROR	Kildemo et al, "A direct robust feedback method for growth control of optical coatings by multiwavelength ellipsometry"; <u>Thin Solid Films</u> , Vol. 313-314; Feb. 1998; pages 484-489;
CROR	Kildemo et al, "Real time control of the growth of silicon alloy multilayers by multiwavelength ellipsometry"; <u>Thin Solid Films</u> ; Vol. 290-291; Dec. 1996; pages 46-50;
CROR	Brevillon, "Phase Modulated Ellipsometry From the Ultraviolet to the Infrared: In Situ Application to the Growth of Semiconductors"; <u>Progress in Crystal Growth and Characterization of Materials</u> ; Vol. 27, No. 1 (1993); pages 1-87;
CROR	Search Report issued in French Application No. 00 10532.

Examiner Signature	<i>Carlos R. Ortiz Rodriguez</i>	Date Considered	03/07/03
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